

Docket No.: 240416US0DIV/hyc



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Masakazu KANECHIKA, et al.

SERIAL NUMBER: 10/618,085

GROUP: 2813

FILED: July 14, 2003

EXAMINER: Tuan H. NGUYEN

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND
SEMICONDUCTOR DEVICE

REQUEST FOR PRIORITY ACKNOWLEDGMENT UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION

MAIL STOP ISSUE FEE
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

SIR:

In the matter of the above-identified application for patent, notice is hereby given that the Applicant(s) claim as priority:

<u>Country</u>	<u>Application No.</u>	<u>Month/Day/Year</u>
Japan	10-313976	October 16, 1998
Japan	11-092855	March 31, 1999
Japan	11-172024	June 18, 1999
Japan	11-242883	August 30, 1999

A Certified copy of the corresponding Convention Application was filed in Serial Number 09/420,524, filed October 18, 1999, of which this application is a Divisional.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon

A handwritten signature in black ink, appearing to read "Joseph Scafetta Jr."

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